LAPIS Rec'd PCT/PTO 12 FEB 2007:

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q93721

Hans-Juergen ROSTALSKI, et al.

Appln. No.: 10/571,267

Group Art Unit: Not Yet Assigned

Confirmation No.: 6099 Examiner: Not Yet Assigned

Filed: March 9, 2006

For: LITHOGRAPHY LENS SYSTEM AND PROJECTION EXPOSURE SYSTEM

PROVIDED WITH AT LEAST ONE LITHOGRAPHY LENS SYSTEM OF THIS TYPE

RESPONSE TO NOTIFICATION OF MISSING REQUIREMENTS UNDER 35 U.S.C. 371 IN THE UNITED STATES DESIGNATED/ELECTED OFFICE (DO/EO/US)

MAIL STOP PCT

Commissioner for Patents P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the "Notification of Missing Requirements Under 35 U.S.C. 371 in the United States Designated/Elected Office (DO/EO/US)," for the above application, Applicant respectfully submits herewith copies of the Declaration for the above identified application properly executed by the inventors. Also filed herewith is an an Information Disclosure Statement with PTO/SB/08 A & B (modified)) and fifteen (15) references, an Excess Claim Fee Payment Letter, a Preliminary Amendment and copies of an executed Assignment with PTO Form 1595.

Checks for the statutory fee of \$130.00, the excess claim fee of \$50.00 and the recordation fee of \$40.00 are attached. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880.

Response Notification of Missing Requirements USSN 10/571,267 Page 2

Please also credit any overpayments to said Deposit Account. A duplicate copy of this paper is attached. Since the initial response date fell on a weekend, the filing of this response on Monday February 12, 2007, is considered timely.

Respectfully submitted,

Registration No. 36,359

George F. Lehnigk

SUGHRUE MION, PLLC

Telephone: (202) 293-7060 Facsimile: (202) 293-7860

> WASHINGTON OFFICE 23373

CUSTOMER NUMBER

GFL/plr

Date: February 12, 2007

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EXCESS CLAIM FEE PAYMENT LETTER

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

A Preliminary Amendment is attached hereto for concurrent filing in the above-identified application. The resulting excess claim fee has been calculated as shown below:

	After Amendment	Highest No. Previously Paid For	I					
All Claims	21 -	20	=	1	X	\$50.00	=	\$50.00
Independent	3 -	3	=		X	\$200.00	=	\$.00
				ТОТ	AL		=	\$50.00

A check for the statutory fee of \$50.00 is attached. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this letter is enclosed.

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